

3 PC2
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroataka KAWATA et al.

Application No.: 10/756,409

Filed: January 14, 2004

For: TRANSISTOR AND METHOD OF
MANUFACTURING THE SAME, ELECTRO-
OPTICAL DEVICE, SEMICONDUCTOR
DEVICE, AND ELECTRONIC APPARATUS

Group Art Unit: 2814

Examiner: T. LE

Docket No.: 118006

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

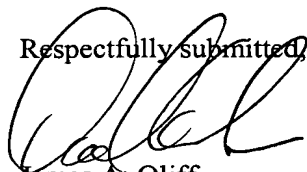
In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination.

☒ Applicants further request entry and consideration of the attached Amendment.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 181535 in the amount of ☒ \$790.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,



James A. Oliff
Registration No. 27,075

Daniel A. Tanner, III
Registration No. 54,734

JAO:DAT/jam

Date: June 30, 2006

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>

07/03/2006 SZEWDIE1 00000053 10756409

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